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E.	TRADENA re patent	•

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

re patent application of:)	Before the Examiner:
Han H. Nee)	Elizabeth Evans Mulvaney
Application No.: 10/763,697)	C. A. Hair
Filed: January 23, 2004)	Group Art Unit: 1774
METAL ALLOYS FOR THE REFLECTIVE)	
OR THE SEMI-REFLECTIVE LAYER OF)	
AN OPTICAL STORAGE MEDIUM)	

SECOND SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Pursuant to the duty of disclosure embodied in 37 C. F. R. § 1.56, Applicant wishes to bring to the attention of the Examiner the following.

This information has not been previously submitted in this application, and has not been heretofore cited by the Examiner. Copies of the listed references with an "*" adjacent the number are not being provided pursuant to 37 C.F.R. § 1.98(d), because they were previously considered in an application to which priority is claimed under 35 U.S.C. § 120 as follows. This application is a continuation of Application No. 10/457,935, filed June 10, 2003, which is a continuation-in-part of

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail on November 10, 2004, in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Signature of Registered Representative: John J. Emanuele

2nd Supplemental Information Disclosure Statement

Applicant: Han Nee Application No.: 10/763,697 Filed: January 23, 2004

Page 1

Application No. 10/342,649, filed January 15, 2003, now U.S. Patent No. 6,790,503, issued on

September 14, 2004, which is a continuation-in-part of Application No. 10/090,855, filed March 4,

2002, now U.S. Patent No. 6,764,735 issued, on July 20, 2004, which is a continuation-in-part of

Application No. 09/661,062, filed September 13, 2000, now Patent No. 6,451,402, issued on

September 17, 2002, which is a continuation-in-part of Application No. 09/557,135, filed April 25,

2000, Abandoned, which is a continuation-in-part of Application No. 09/438,864, filed November 12,

1999, now Patent No. 6,280,811, issued on August 28, 2001, which is a continuation-in-part of

Application No. 09/102,163, filed June 22, 1998, now Patent No. 6,007,889, issued on October 28,

2002, and is also a continuation-in-part of Application No. 10/409,037, filed on April 8, 2003, which is

a continuation-in-part of Application No. 09/834,775, filed April 13, 2001, now Patent No. 6,544,616,

issued on April 8, 2003, Abandoned, which claims the benefit of Provisional Application No.

60/219,843. These patents have been identified on an accompanying INFORMATION DISCLOSURE

CITATION FORM.

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This Statement is being submitted after the mailing of an Office Action on the merits, but before

the mailing of any Final Office Action. The fee of \$180 as required under 37 C.F.R.§ 1.17(p) is

enclosed. Therefore, it is believed that no additional fees are due. However, the Commissioner is

authorized to charge any fee due as set forth in § 1.17(p) and to charge any additional fees which may

be due with this filing to Deposit Account No. 23-3030, but not to include any payment of issue fees.

Enclosed are references in the Japanese language. By way of a concise statement of the

relevance of the enclosed Japanese references in accordance with 37 C.F.R. § 1.98(a)(3)(I) also

enclosed are abstracts of some of these references in the English language. Also provided for some of

these references are portions of translations into the English language that were provided to the Office

2nd Supplemental Information Disclosure Statement

Applicant: Han Nee

by a third party.

The filing of this Information Disclosure Statement shall not be construed as an admission that the information cited is, or is considered to be, material to patentability as defined in § 1.56(b).

Respectfully submitted:

John J. Emanuele

Reg. No. 51,653

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WEMMH/SB/08A (4/03)

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NFORM	[AT]	ION DISCLOSUR	E CITATION	Atty. Docket N	o.: 7272-46	Application	No.: 10/763,697
Page 1of :		ges	 		TT NI		
2/2-40/312	302			Applicant: Ha	in H. Nee		
				Filing Date: Ja	nuary 23, 200	94 Group Art U	nit: 1774
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				Filing Date: January 2.	3, 2004	Group Art Unit	: 1774
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Page 4 of 5 7272-46/31236	2	NOV 1 5 2004	8	Applicant : Han H.	Nee			
				Filing Date: Januar	y 23, 2004	Group Art Unit:	1774	
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INFORM Page 5 of		ON DISCIONURS CITATION	Atty. Docket No.: 7272-46	Application No.: 10/763,697	
7272-46/31:		HOV 1 5 7004 DE	Applicant: Han H. Nee		
		The second	Filing Date: January 23, 2004	Group Art Unit: 1774	
		OTHER PRIOR ART - NO	N PATENT LITERATURE D	OCUMENTS	
Examiner Initials*	Cite No. 1	Include name of the author (in CAPITAL LETT symposium, catalog, etc.), date, p	TERS), title of the article (when appropriate), ti page(s), volume-issue number(s) publisher city a		T
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¹ Applicant's unique citation designation number (optional). ² Applicant is to place a check mark here if English language Translation is attached.